

Application No. 10/823,887

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application Serial No ..... 10/823,887  
Filing Date ..... April 13, 2004  
Inventorship ..... Brian A. Vaartstra  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 1722  
Examiner ..... R. Kunemund  
Attorney's Docket No ..... MI22-2489  
Title: ..... Aluminum-Containing Material and Atomic Layer Deposition Methods

**RESPONSE TO AUGUST 9, 2005 OFFICE ACTION**

To: Mail Stop Amendments  
Commissioner for Patents and Trademarks  
P.O. Box 1450  
Alexandria, VA 22313-1450

From: James E. Lake (Tel. 509-624-4276; Fax 509-838-3424)  
Wells St. John P.S.  
601 W. First Avenue, Suite 1300  
Spokane, WA 99201-3828

**AMENDMENTS**

No amendments.